

PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1
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EPAS ID: PAT6751667

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
GUANGTAO HAN	06/07/2021
RECEIVING PARTY DATA	
Name:	JOULWATT TECHNOLOGY CO., LTD
Street Address:	RM 901-23, 9TH FLOOR, BLD. 4, 298 ZHENHUA RD.
Internal Address:	SANDUN TOWN XIHU DISTRICT
City:	HANGZHOU
State/Country:	CHINA
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	17342489
CORRESPONDENCE DATA	
Fax Number:	
<i>Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.</i>	
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Correspondent Name:	CATHERINE YE
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ATTORNEY DOCKET NUMBER:	21216CC
NAME OF SUBMITTER:	QING YE
SIGNATURE:	/Qing Ye/
DATE SIGNED:	06/09/2021
Total Attachments: 3	
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source=21216CC_exeAssignement#page2.tif	
source=21216CC_exeAssignement#page3.tif	

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**SEMICONDUCTOR STRUCTURE AND METHOD FOR MANUFACTURING THE
SAME**

ASSIGNMENT

WHEREAS I/We, the below named inventor(s),
Guangtao HAN of Hangzhou, China

hereby sell and assign to Joulwatt Technology Co., Ltd., whose post office address is Room 901-23, 9th Floor, Building 4, West Port Development Center, NO. 298 ZHEN HUA Road, Sandun Town Xihu District, Hangzhou Zhejiang Province 310030, China, hereinafter referred to as "Company", its successors and assigns our entire respective rights, titles and interests in and to the invention and improvements invented and originated by us and for United States Patent currently entitled:

**SEMICONDUCTOR STRUCTURE AND METHOD FOR MANUFACTURING THE
SAME**

Executed concurrently herewith,

and any and all applications for patent and patents therefrom in any and all countries, including all divisions, continuations, reexaminations and reissues thereof, and all rights of priority resulting from the filing of said United States application, and authorize and request any official whose duty it is to issue patents, to issue any patent on said inventions and improvements resulting therefrom to said Company, or its successors or assigns and agree that on request and without further consideration, but at the expense of said Company, we will communicate to said Company or its representatives or nominees any facts known to us respecting said inventions and improvements and testify in any legal proceeding, sign all lawful papers, execute all divisional, continuation, reexamination and reissue applications, make all rightful oaths and generally do everything possible to aid said Company, its successors, assigns, and nominees to obtain and enforce proper patent protection for said invention and its improvements in all countries.

AND We/I hereby authorize and request our/my agents, USPTO customer number 93229, whose address is 106 Oakland PI, Los Gatos, CA 95032, to insert hereon any

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identification necessary or desirable for recordation of this document, including the filing date and application number of said application when known.

AND We/I hereby covenant for ourselves/myself and our/my legal representatives, and agree with said Company, its successors and assigns, that We/I have granted no right or license to make, use, sell or offer to sell said improvements, to anyone except said Company, that prior to the execution of this assignment document, our/my right, title and interest in said improvements had not been otherwise encumbered, and that We/I have not and will not execute any instrument in conflict therewith;

AND We/I do hereby authorize and request the Director of the United States Patent and Trademark Office to issue any and all letters patent which may be granted upon said United States applications, or upon said improvements or any parts thereof when granted, to said Company.

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SAME

INVENTOR 1

Signature: Guangtao HAN Date: 06/07/2021
Guangtao HAN

Witnessed by: Xinran Wang Date: 06/07/2021
Xinran WANG

Witnessed by: Fei Ye Date: 06/07/2021
Fei YE
